

Notice of References Cited	Application/Control No. 10/709,908	Applicant(s)/Patent Under Reexamination IDE, HIROYUKI	
	Examiner Chia-Wei A. Chen	Art Unit 2622	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0057354	05-2002	YANAI et al.	348/273
*	B	US-2003/0156209	08-2003	YANAI, TOSHIKAZU	348/272
*	C	US-6,628,328	09-2003	Yokouchi et al.	348/221.1
	D	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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